



ISWAF #



Docket No.: 220143US2

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

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RE: Application Serial No.: 10/083,596

Applicants: Hisaji OYAKE, et al.

Filing Date: February 27, 2002

For: METHOD FOR PRODUCING PHOTORESIST
MASTER FOR OPTICAL INFORMATION MEDIUM,
AND METHOD FOR PRODUCING STAMPER FOR
OPTICAL INFORMATION MEDIUM

Group Art Unit: 1756

Examiner: ANGEBRANNDT, M.

SIR:

Attached hereto for filing are the following papers:

Notice of Appeal

Request for Extension of Time (3 months)

Our credit card payment form in the amount of \$1,320.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
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